

Hyperion Research Recognizes Kim as 'Advanced Solution' in its Workflow Automation MarketView™ Report

**Kim also identified as a Market Leader in Document Generation
plus Highly Innovative for its Data Model**

Atlanta, June 28, 2024: Kim (www.kimdocument.com), the no-code, SaaS, patent-protected document generation, assembly, and workflow and data automation platform, is pleased to announce its recognition in the prestigious 'Advanced Solutions' category by the Hyperion MarketView™ Research Program. You can request the full report [here](#).

Hyperion Research, an Epiq Company, reviewed 19 companies and categorized them into three levels: Market Participant, Market Notable, and Advanced Solution. An 'Advanced Solution' vendor demonstrates significant strength in both product functionality and overall solution capabilities; meets or exceeds all Key Solution Components; has a strong record of client satisfaction and market share; provides a consistent flow of valuable enhancements; has a highly regarded management team and organization; and has demonstrated financial stability.

In addition to being an Advanced Solution, Kim received further recognition in the following areas:

- **Market Leader in Document Generation:** Kim's Word Add-In supports rapid document assembly with embedded templates, clauses, and playbooks.
- **Highly Innovative for its Data Model:** Kim's capabilities include the assimilation of data points from uploaded documents, supporting sophisticated and scalable document management, forensics, and enterprise search.

"I am delighted for our hard-working team that Kim has been recognized as an 'Advanced Solution,'" said **Karl Chapman, CEO** at Kim. "We also owe our customers a big thank you for helping us refine and evolve our products.

I am excited that we have been recognized as a market leader in document generation. Document automation and assembly are key parts of Kim, and we generate thousands of contracts every month.

However, I am really pleased with the comments about our data and assimilation model. The cornerstones of AI are data and context. Kim makes it easy for customers to capture and use data, and we assimilate context from the documents we upload. Because of this, we can generate enterprise applications from content, not just content from content."

For further information and to request a Kim demonstration, please contact Becky Roberts:
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NEWS RELEASE



About Kim

Kim is a no-code, SaaS, patent-protected document generation, assembly and workflow automation tool. Kim's Enterprise solution is proven with Fortune 500 organizations in legal, compliance, contract management, company secretarial, office productivity and other functions.

Kim has two patents. When a DOCX template is uploaded into the Kim software it gains additional knowledge by learning the structural composition of each template and it can interface with any authenticated and authorized client over HTTPS with an intelligent understanding of the correctness of the data being supplied. This enables the automatic extraction of tags from the multiple sample documents, the storing of the tags in a data schema separate from the documents, automatically generating structural schemes from the tags, automatically creating document templates from the sample documents and processing the document templates to create unique identifiers (see 'Patent Headlines' section and the Kim patent: <https://patents.justia.com/patent/10817662>).

For more information visit www.kimdocument.com.

About Hyperion Research

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